



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Volker Härle et al.                      Art Unit : 2818  
Serial No. : 10/813,530                              Examiner : Chuong A. Luu  
Filed : March 29, 2004  
Title : METHOD FOR FABRICATING A SEMICONDUCTOR COMPONENT BASED  
ON A NITRIDE COMPOUND SEMICONDUCTOR

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF SEPTEMBER 27, 2005

In reply to the Office Action of September 27, 2005, applicant submits the following  
remarks:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date of Deposit

1/10/2006

Signature

Debbie Nast

Typed or Printed Name of Person Signing Certificate